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1733

GR 98 P 4137 P

BOX AF

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By:

Date: May 26, 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 09/761,594 Confirmation No. 5815  
Applicant : Hans-Jürgen Hacke et al.  
Filed : January 16, 2001  
TC/A.U. : 1733  
Examiner : John T. Haran  
Title: : Semiconductor Device in Chip Format and  
Method for Producing It  
  
Docket No. : GR 98 P 4137 P  
Customer No. : 24131

BOX AF

Hon. Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE under 37 C.F.R. § 1.116**

S i r :

In response to the final Office action dated March 10, 2004,  
please consider the following remarks or arguments:

**Remarks/Arguments** begin on page 2 of this paper.